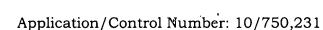
| | Application No. | Applicant(s) |
|---|--|---|
| Notice of Allowability | 10/750,231 | WILLEMS ET AL. |
| | Examiner | Art Unit |
| | Tianjie Chen | 2627 |
| The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313 | (OR REMAINS) CLOSED in this ap or other appropriate communicatio IGHTS. This application is subject | oplication. If not included on will be mailed in due course. THIS |
| 2. ☑ The allowed claim(s) is/are <u>1-18</u> . | | |
| 3. ☐ Acknowledgment is made of a claim for foreign priority unexpense and a claim for foreign priority documents have a claim for foreign documents have a claim for foreign priority documents have a claim foreign priority documents have a cl | e been received. e been received in Application No cuments have been received in this of this communication to file a reply MENT of this application. hitted. Note the attached EXAMINER es reason(s) why the oath or declar st be submitted. son's Patent Drawing Review (PTC s Amendment / Comment or in the 1.84(c)) should be written on the draw the header according to 37 CFR 1.121 stit of BIOLOGICAL MATERIAL | s national stage application from the complying with the requirements R'S AMENDMENT or NOTICE OF ration is deficient. 0-948) attached Office action of rings in the front (not the back) of (id). must be submitted. Note the |
| Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material | 5. ☐ Notice of Informal 6. ☐ Interview Summar Paper No./Mail Da 7. ☐ Examiner's Amend 8. ☑ Examiner's Statem 9. ☐ Other | y (PTO-413), ate |



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REASONS FOR ALLOWANCE

1. Claims 1-15 and 18-20 are allowed.

The following is an examiner's statement of reasons for allowance:

- With regard to independent claim 1, as a reference of record, Ando et al (US 4,831,472) shows a storage medium load and unload apparatus for diverting a storage medium insertion impact force, comprising: a shuttle having a first pin with a first radius extending from a side surface of the shuttle and a protrusion having a posterior edge extending from the side surface, wherein the posterior edge is displaced a first distance from a center of the first pin; and a fixed side plate having a flange with a vertical edge and a first slot with which the first pin is engaged has an anterior edge and a curved posterior edge with a first width between the anterior edge and the curved posterior edge, wherein the vertical edge of the flange is displaced a second distance from the anterior edge of the first slot; but fails to show that the first slot has a curved posterior edge, and wherein a sum of the first width and the second distance is greater than the sum of the first distance and the first radius.
- Applicant asserts: in this invention "A protrusion extending from a shuttle side surface is positioned to impact a flange of a fixed side plate of the apparatus such that the impact force resulting from insertion of a storage medium into the shuttle is conveyed to the protrusion and the flange (Specification, p. 19).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably Application/Control Number: 10/750,231

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k 1. . . .

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Tianjie Chen whose telephone number is 571-272-

7570. The examiner can normally be reached on 8:00-4:30, Mon-Fri.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Hoa Nguyen can be reached on 571-272-7579. The fax phone number for

the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR

only. For more information about the PAIR system, see http://pair-direct.uspto.gov.

Should you have questions on access to the Private PAIR system, contact the

Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like

assistance from a USPTO Customer Service Representative or access to the automated

information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

TIANJIE CHEN

PRIMARY EXAMINER

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